

# **Easy to Use Run-to-run Control of Heating Processes with Rapid Thermal Gradients**

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# Run-to-run Update of Continuous Control

- Processes with continuous control
- Illustrated for thermal processing, applicable to other processes.
- Many applications of run-to-run update for processing parameters based on the end result of the batch
- This talk: update of continuous control
- Focus: robust, simple, reliable, easy to use and setup
- Accommodating to adjustment or change of equipment and recipe

# Rapid Thermal Processing Control

- RTP requires tight control
  - rapid temperature ramping rates
  - closely follow temperature profiles
  - keep thermal gradients low
  - continuous control through a run
- Control issues
  - highly nonlinear dynamics of the process
  - heating zone cross-coupling
  - detailed and accurate dynamical models are expensive to get

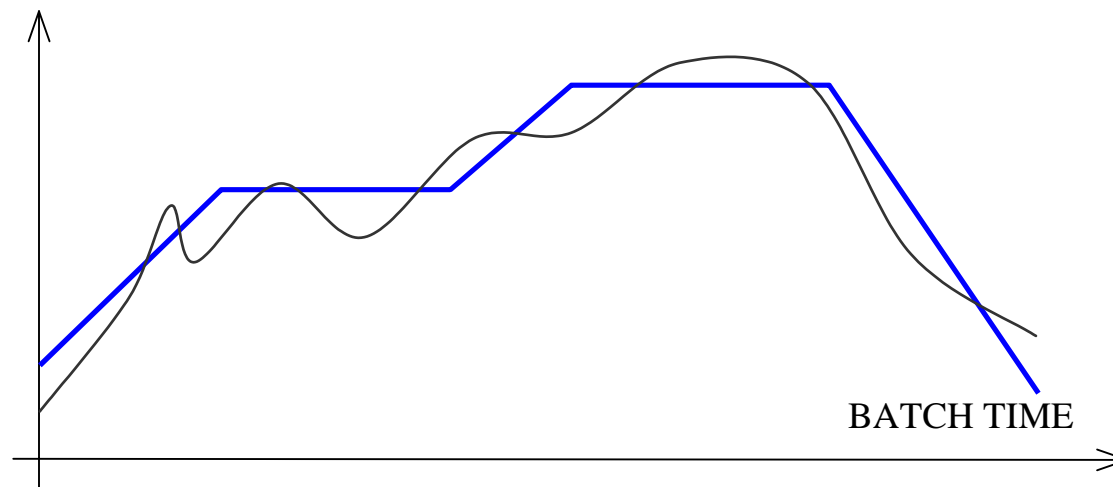
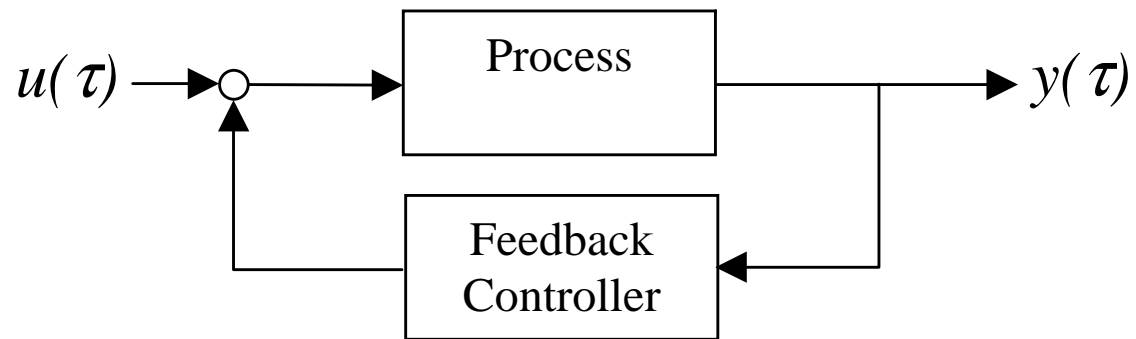
# RTP Control Approaches

- PID control of each zone temperature
  - simple conceptually
  - easy to maintain, robust to control parameter choice
  - low performance, slow response
- APC: Multivariable feedback control, e.g., MPC
  - conceptually complicated, need for a PhD engineer
  - requires careful model identification and tuning
  - good performance

# RTP Control Approaches (cont'd)

- ILC (Iterative Learning Control)
  - ILC = Run-to-run update of the feedforward sequence
  - conceptually simple
  - very robust
  - excellent performance
  - automated identification and tuning is possible
  - subject of this presentation
- ILC history
  - the concept first developed for robotics control
  - now used for process control as well

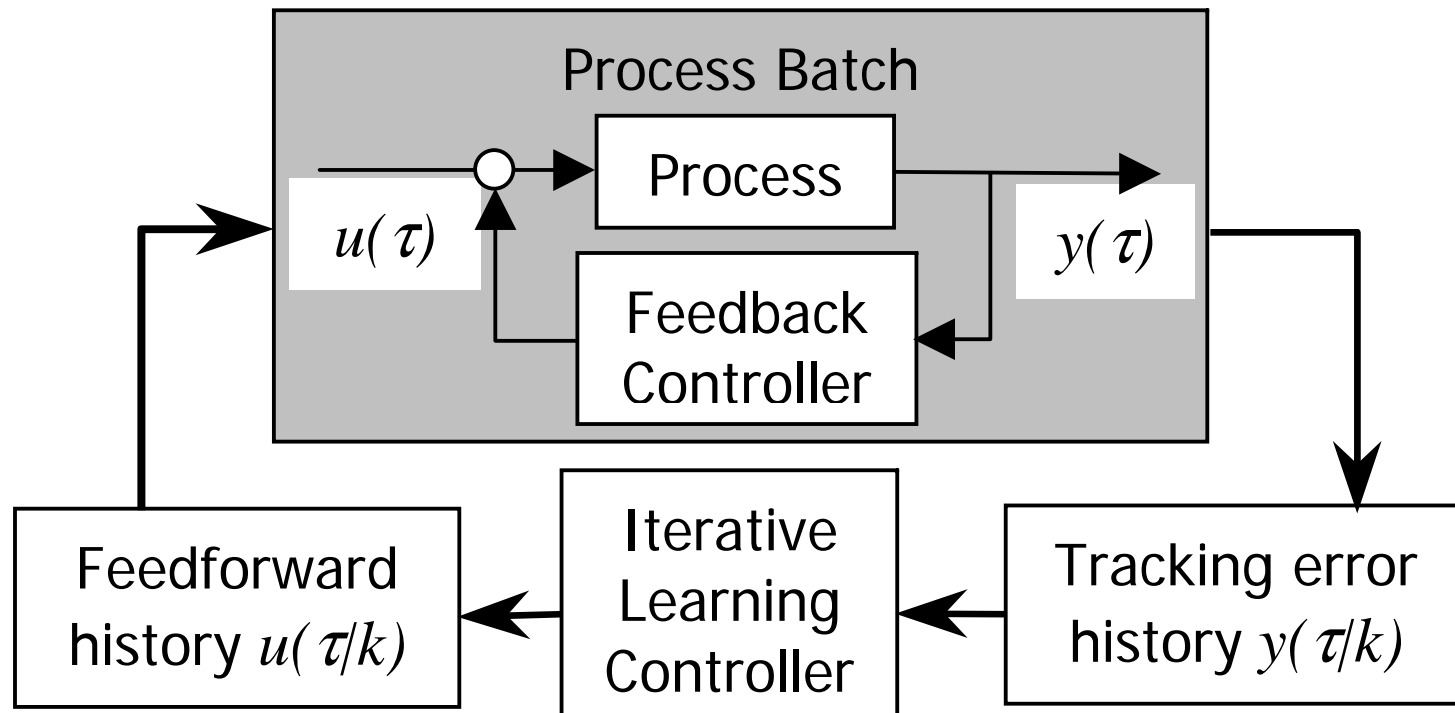
# ILC Concept: Feedforward Control



- $\tau$  is local time,  $0 \leq \tau \leq T$

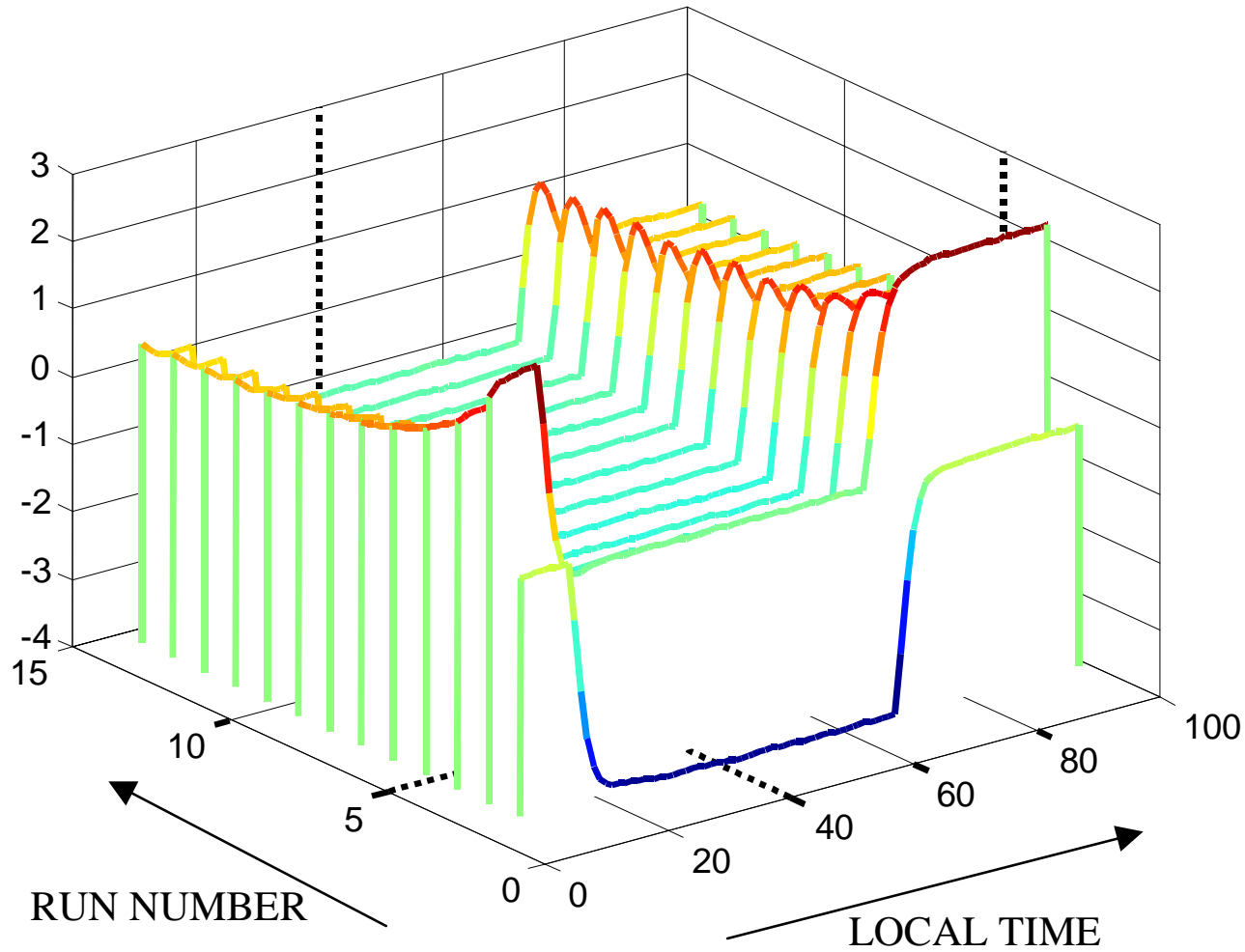
# ILC Concept: Run-to-run update

## Iterative Learning Control (ILC) Concept



- $\tau$  is local time,  $0 \leq \tau \leq T$
- $k$  is run number
- 2-D system evolving in  $\tau$  and  $k$

# ILC as a 2-Dimensional System

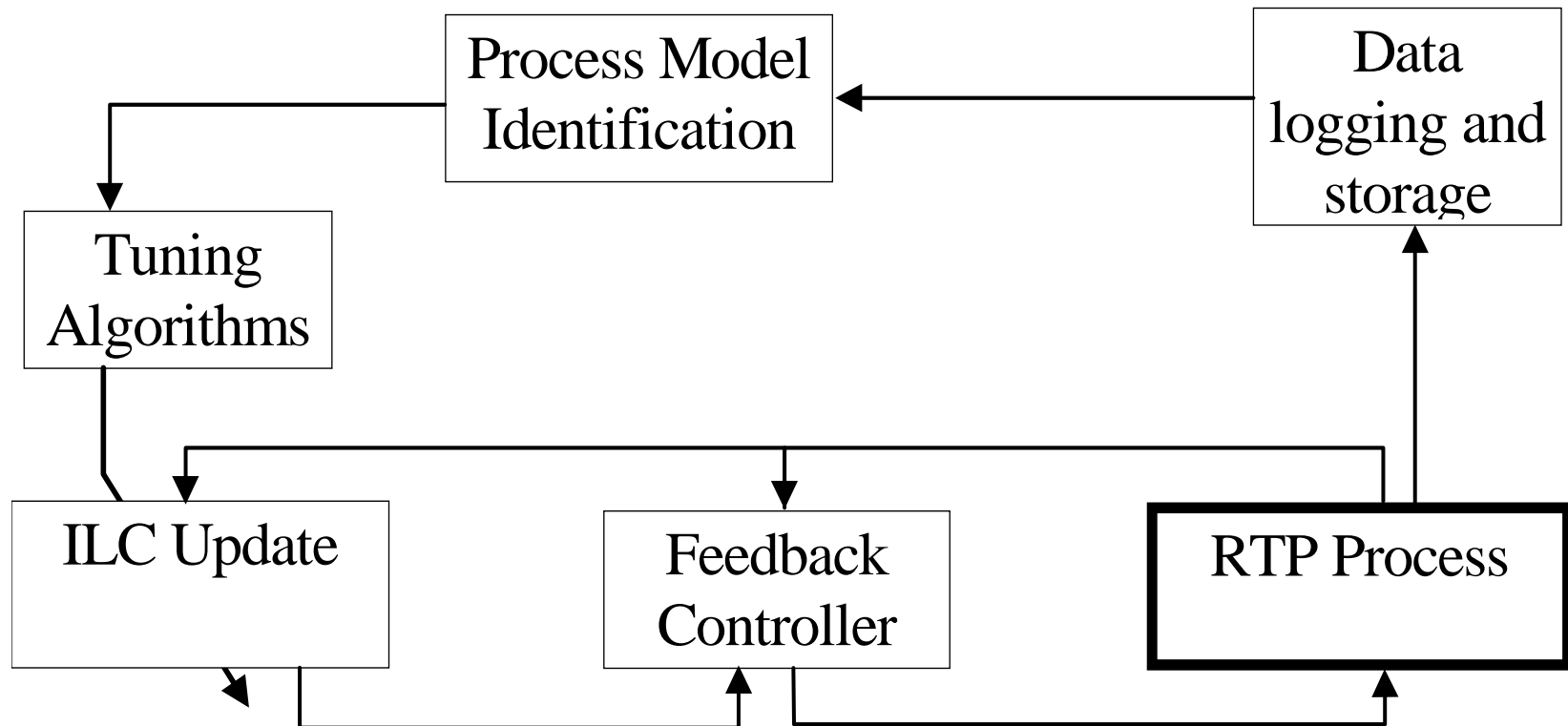


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# ILC Advantages

- ILC is non-causal in local time - “future” error history is known from the previous run
- No phase lag, hence, very good robustness while maintaining excellent performance
- Approximate model is sufficient, hence, easy process identification and tuning
- Honeywell’s ILC technology comes as a package including:
  - Run-time supervisory controller
  - Tuning tool
  - Identification tool

# ILC Application Package



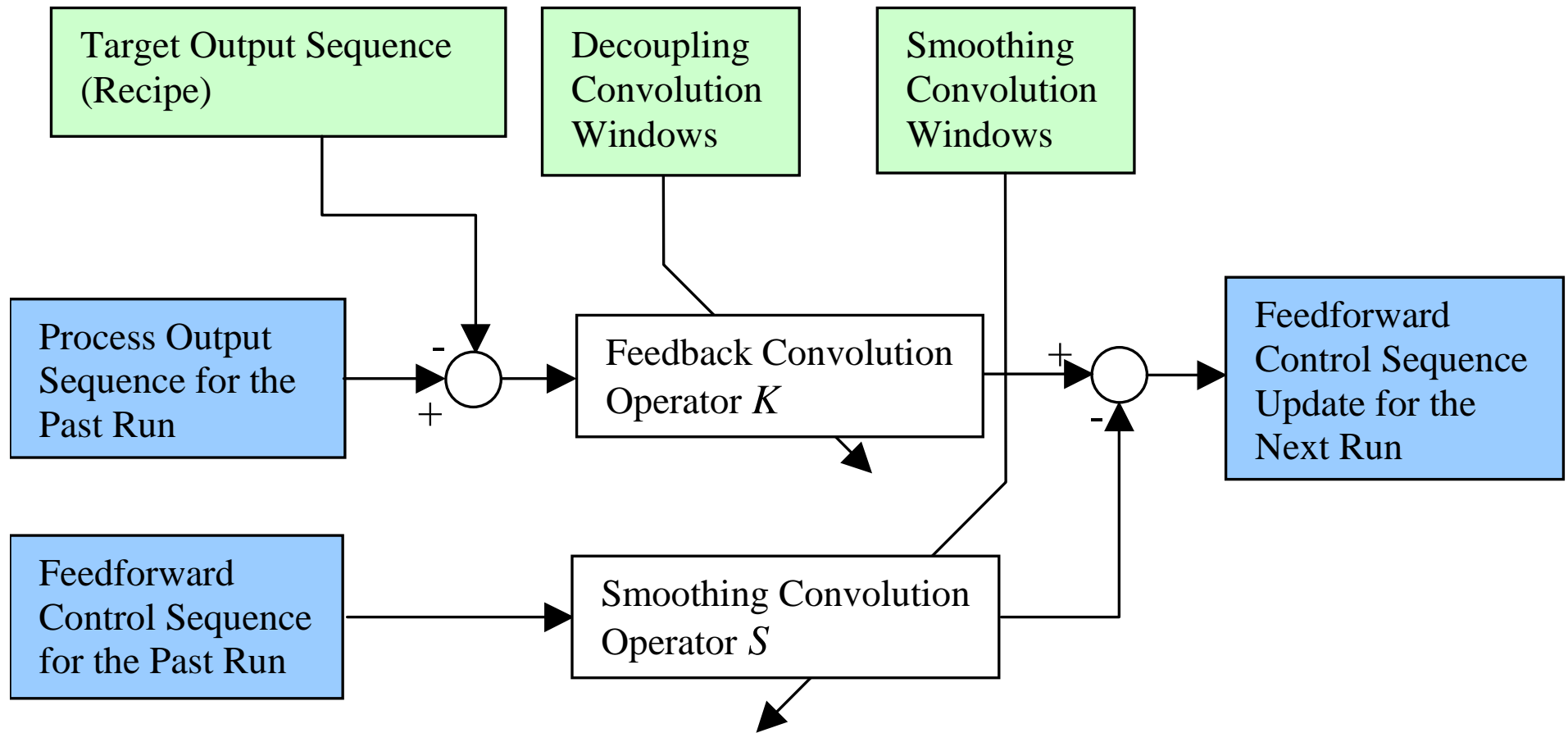
# ILC Run-time Update

- ILC update rule

$$u(t | n + 1) = u(t | n) - (K * e)(t | n) - (S * u)(t | n)$$

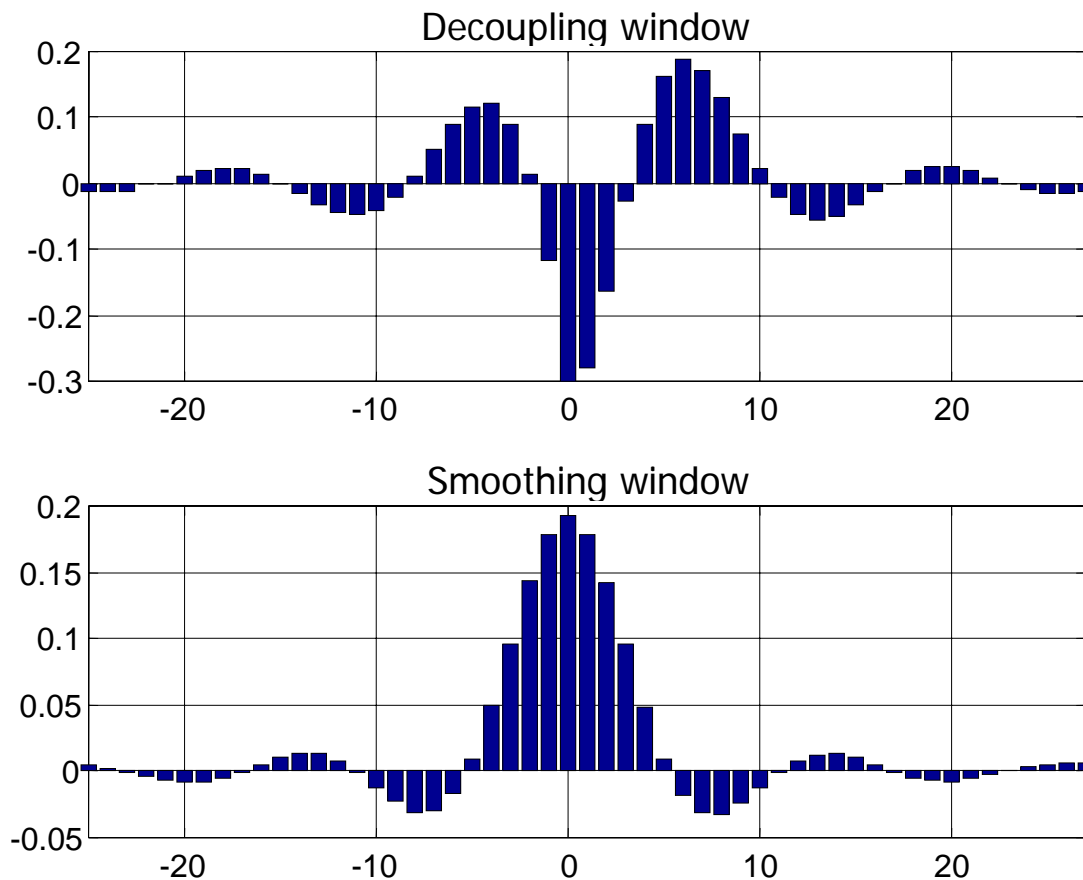
- $t$  - local time
- $n$  - run number
- $*$  - denotes convolution
- $K$  - decoupling convolution operators
- $S$  - smoothing convolution operators

# ILC Run-time Update



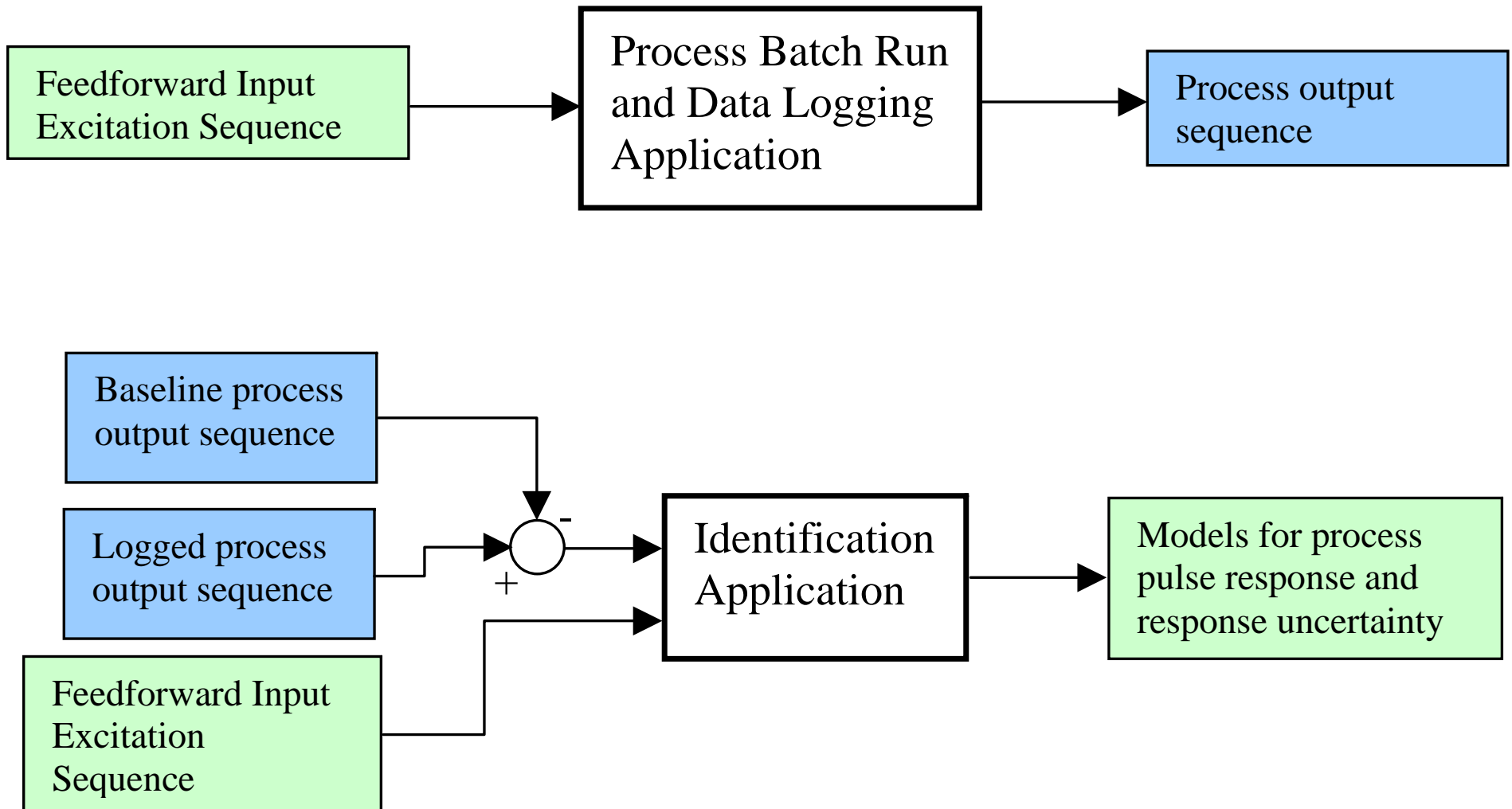
# ILC Run-time Update

- Example: Convolution windows for ILC update

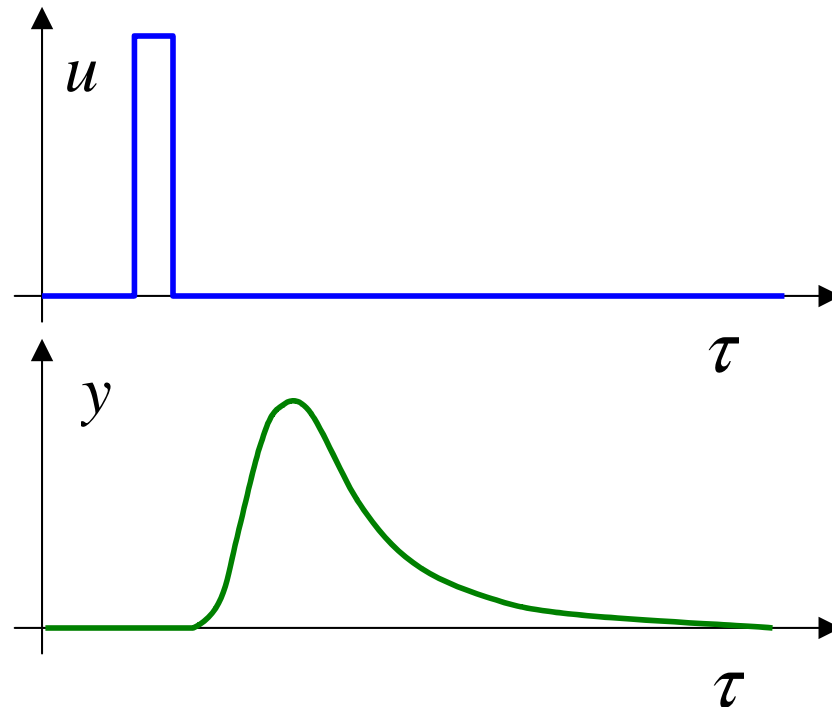


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# Identification Application



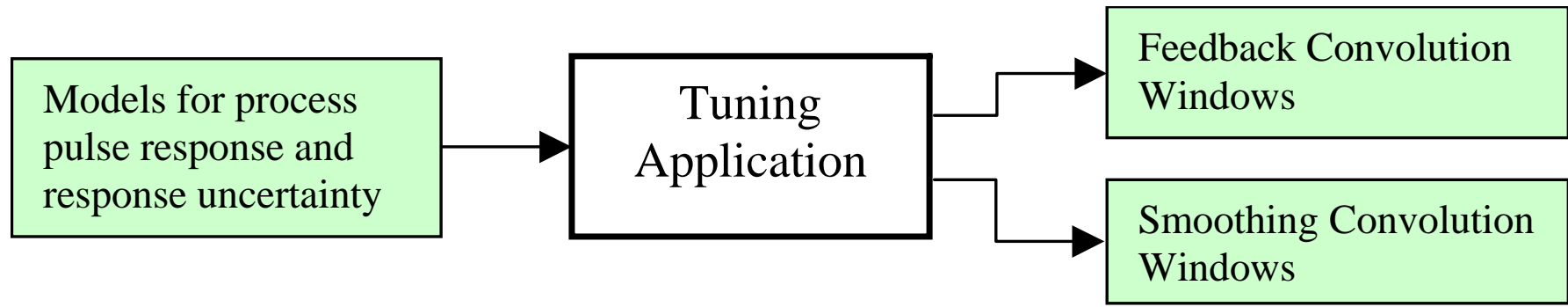
# Model Identification: FIR model



- FIR model identification from data is standard for industrial MPC packages
- Robust identification of an average FIR model from an experiment with a single batch run is possible

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# Tuning Application



# ILC Update Tuning (Controller Design)

## ILC Design Problem:

- The update converges quickly
- The update is robust to modeling errors
- Limited control effort is required
- Insensitive to noise
- Automated design

## ILC Analysis Problem:

- Evaluate stability (convergence)
- Find robust stability margin
- Estimate control effort required

# Controller Design

$$y = Gu$$

$$J(\omega) = |e(\omega)|^2 + |R(\omega)u(\omega)|^2 \rightarrow \min$$

$$u_{new}(\omega) = u_{old}(\omega) - K(\omega)e(\omega) - S(\omega)u_{old}(\omega)$$

$$K = \left( G^*(\omega)G(\omega) + R^*(\omega)R(\omega) \right)^{-1} G^*(\omega)$$

$$S = \left( G^*(\omega)G(\omega) + R^*(\omega)R(\omega) \right)^{-1} R^*(\omega) - I$$

# Frequency Domain Controller Design

- Robust stability condition
- Control amplitude constraint

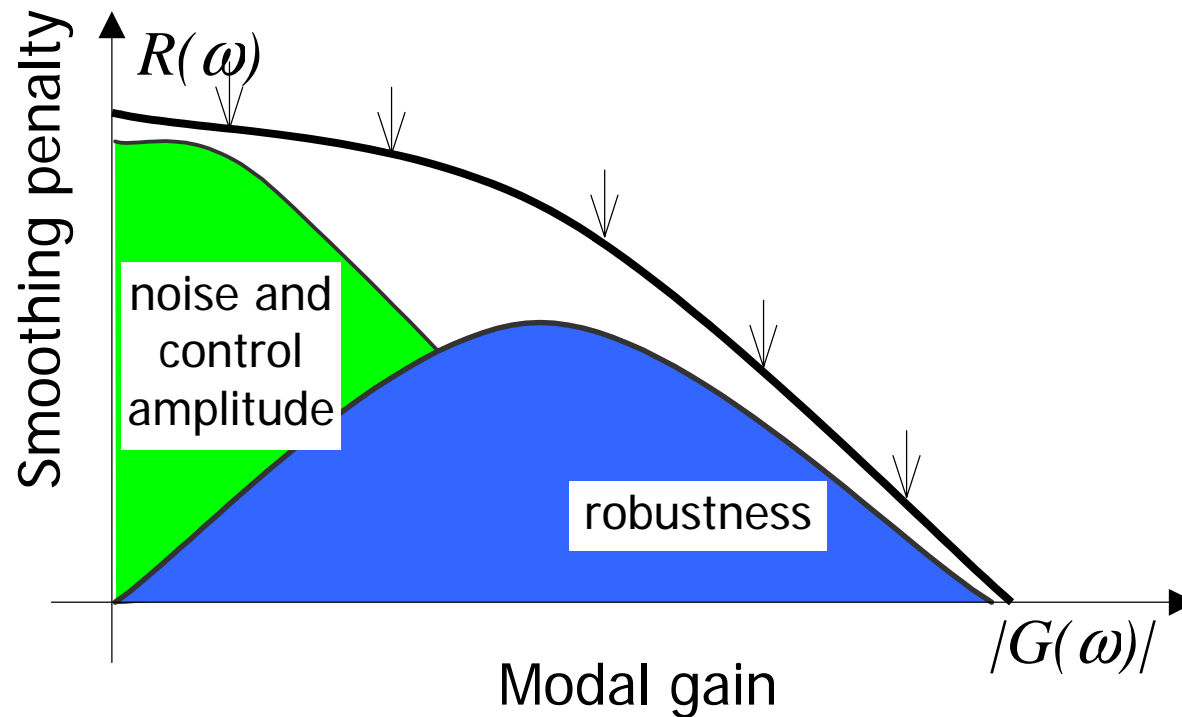
$$R(\omega) > w_0 |G(\omega)| - |G(\omega)|^2$$

- Performance requirement: minimize steady-state error

$$R(\omega) \rightarrow \min$$

- Noise insensitivity

# Frequency Domain Controller Design

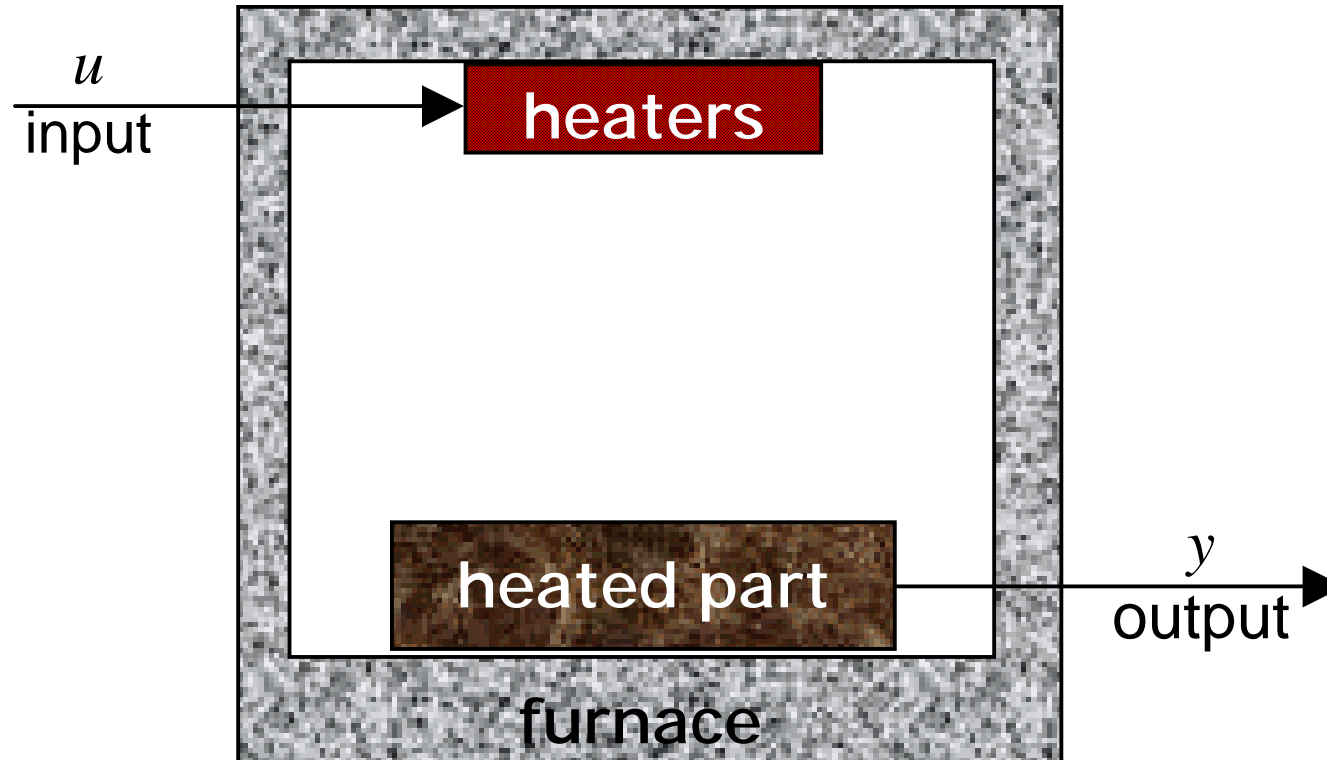


- Noncausal loopshaping design for local time operators
- Related to LQG/LTR and loopshaping control design methods used for flight control design

# Thermal Processing Application

- Carbon composite annealing process
- Military/Aerospace relevant
- More difficult to control than RTP - furnace thermal inertia
- Time scale is proportionally slower than for both process and control

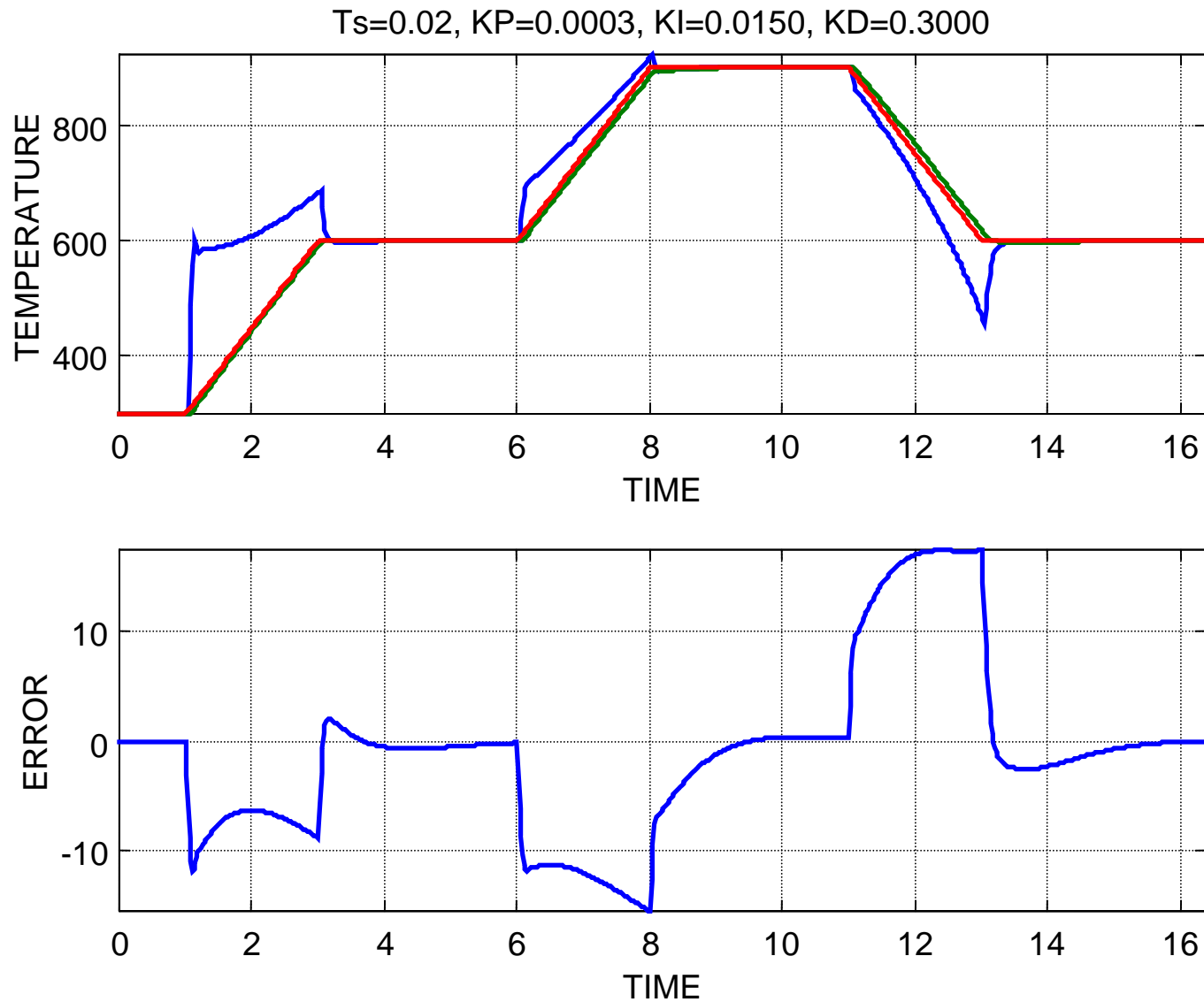
# Thermal Processing Model



- Two states: plant and furnace temperatures
- Nonlinear dynamics: radiation and convection heat transfer

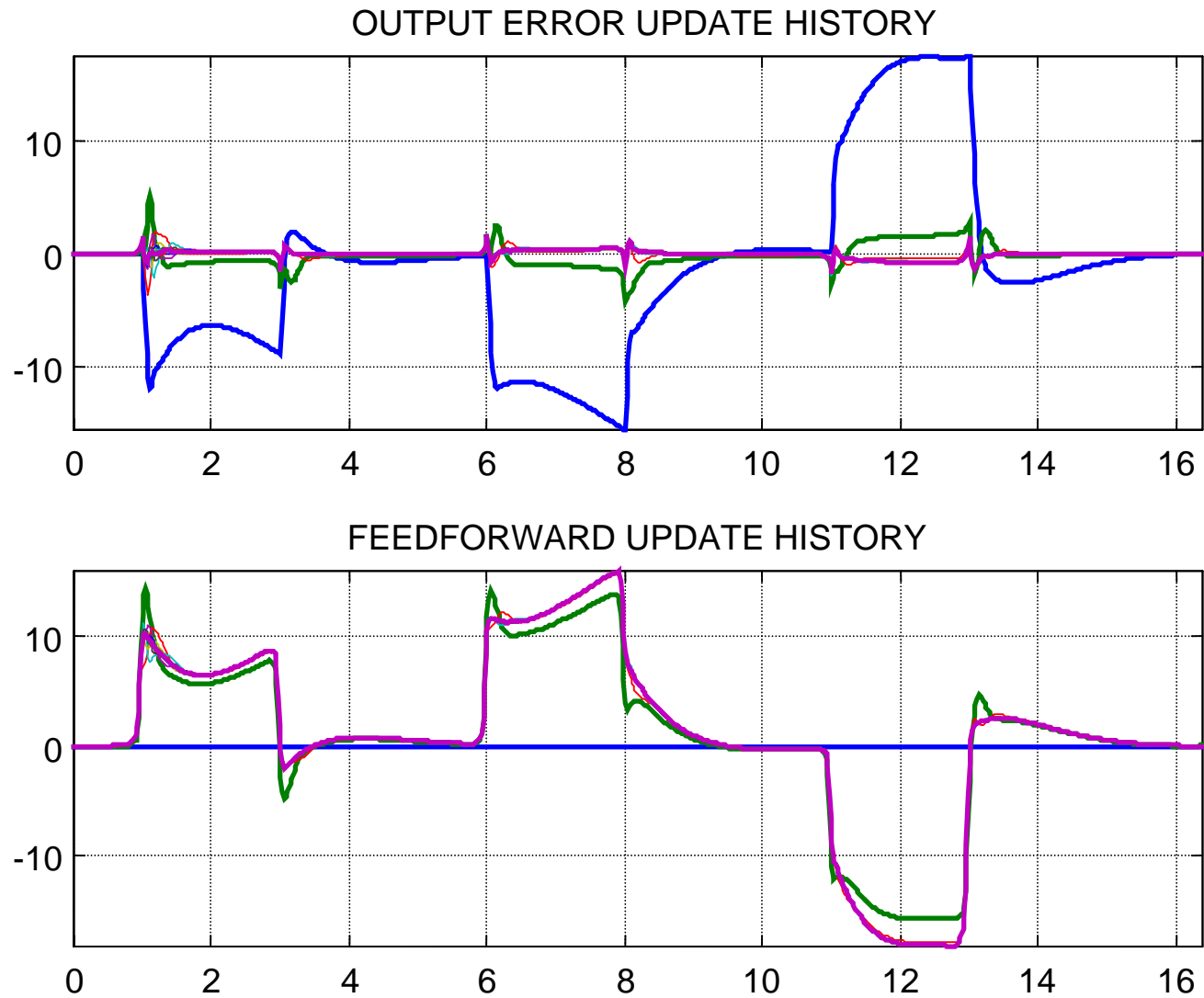
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# Thermal Processing with PID Control



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# ILC Update for Thermal Processing



# ILC Results for Annealing

- Because of the furnace thermal inertia the process is more difficult to control than RTP
- 30% linear model uncertainty because of the process nonlinearity
- ILC feedforward is used on top of a PID feedback control
- Extremely good control performance achieved
  - ILC update converges in 4-5 steps
  - less than 1 degree maximal error
  - ILC feedforward modification is smooth and small

# Conclusions

- Simple and consistent ILC approach for RTP control
- Superior performance, robust, easy to use and maintain
- Simple on-line computations, can be implemented in a low-end processor
- Integrated identification and tuning package based on industrial FIR model
- Automated tuning for operator use
- Control design based on specs: performance, robustness margin, etc; similar to LQG/LTR